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Form PTO-1449

Examiner Ref.

Title

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket	Number	509982000600

Application Number 09/727,530

Applicant

Nickhil JAKATDAR, et al.

Filing Date November 28, 2000

Group Art Unit 28+1 2名77

Mailing Date November 6, 2001

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
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FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO

OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Initials	No.		
HP	1.	Xinhui Niu, "AN INTEGRATED SYSTEM OF OPTICAL METROLOGY FOR DEEP SUB-MICRON LITHOGRAPHY", Electronics Research Lab., College of Engineering UC Berkeley, 4/1999, 139 pgs.	
MP	2.	William H. Press et al., "NUMERICAL RECIPES in C", The Art of Scientific Computing, Sec. Ed., pp. 444-455, Cambridge University Press, 1986.	

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8/24(03

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